Docket No.: 6317P045X2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

ALEXANDER KADYSHEVITCH, ET

Application No.:

10/695,620

Filed:

October 27, 2003

For:

Specimen Current Mapper

Art Group:

2881

Examiner:

Vanore, David A.

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In accordance with the duty of disclosure, enclosed is a copy of IDS Citation Form PTO/SB/08 or PTO-1449, together with copies of the documents cited on that form, except for copies not required to be submitted (e.g., copies of U.S. patents and U.S. published patent applications need not be enclosed). This IDS and IDS Citation Form are being submitted. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

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Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: 7-/2-05

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Complete if Known		
Application Number	10/695,620	
Filing Date	October 27, 2003	
First Named Inventor	Alexander Kadyshevitch	
Art Unit	2881	
Examiner Name	Vanore, David A.	
Attorney Docket Number	6317P045X2	

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²		
		YACOBI ET AL., Scanning Electron Microscopy (Chapter 2), Micro Analysis of Solids, Plenum Press, New York, 1994.			
		YAMADA ET AL., An In-Line Process Monitoring Method Using Electron Beam Induced Substrate Current, Microelectronics-Reliability, March 2001, pages 455-459.			

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